## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:		)	
Hisashi OHTANI et al.		)	Art Unit: 2829
Application No.: 08/807,737		)	
Filed: February 27, 1997		)	Examiner: Evan PERT RECEIVED
For:	METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE	)	AUG 2 6 2003
		)	OFFICE OF PETITIONS

## PETITION FOR WITHDRAWAL FROM ISSUE UNDER 37 C.F.R. 1.313(c)(2)

Mail Stop Petition Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants hereby petition for the withdrawal of this application from issue, under 37 C.F.R. 1.313(c)(2), to consider the Request for Continued Examiner, pursuant to 37 C.F.R. 1.114, as well a Preliminary Amendment and a Information Disclosure Statement, filed on even date herewith. The issue fee for this case was paid on July 8, 2003.

The Commissioner is authorized to charge any deficiencies (except the issue fee) or credit any overpayment to Deposit Account No. 19-2380 (740756-1638). A duplicate copy of this sheet is attached.

Respectfully submitted,

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